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Term	Documents
(18 AND 19).USPT.	54
(L19 AND L18).USPT.	54

Database:

US Patents Full-Text Database
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Derwent World Patents Index
IBM Technical Disclosure Bulletins

Search:

L20

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<u>Set Name</u>	<u>Query</u>	<u>Hit Count</u>	<u>Set Name</u>
side by side			result set

DB=USPT; PLUR=YES; OP=ADJ

<u>L20</u>	L19 and l18	54	<u>L20</u>
<u>L19</u>	L13 near4 l6	3619	<u>L19</u>
<u>L18</u>	L17 and l16	72	<u>L18</u>
<u>L17</u>	pressure	1220419	<u>L17</u>
<u>L16</u>	L15 and l8	74	<u>L16</u>
<u>L15</u>	L14 and l11	1337	<u>L15</u>
<u>L14</u>	l13 near8 l6	5354	<u>L14</u>
<u>L13</u>	l12 or l5	398771	<u>L13</u>
<u>L12</u>	"N.sub.2"	95882	<u>L12</u>
<u>L11</u>	L10 and l4	35564	<u>L11</u>
<u>L10</u>	l1 and l2	107322	<u>L10</u>
<u>L9</u>	bias	245153	<u>L9</u>
<u>L8</u>	rf bias	1135	<u>L8</u>
<u>L7</u>	L6 near8 l5	4205	<u>L7</u>
<u>L6</u>	plasma	131753	<u>L6</u>
<u>L5</u>	nitrogen	361419	<u>L5</u>
<u>L4</u>	l2 near8 l3	60721	<u>L4</u>
<u>L3</u>	remov\$4 or etch\$4	1675688	<u>L3</u>
<u>L2</u>	oxide	464206	<u>L2</u>
<u>L1</u>	semiconduct\$4	269680	<u>L1</u>

END OF SEARCH HISTORY